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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Salman Akram

Serial No.: 09/829,161

Filed: April 9, 2001

For: METALLIZATION STRUCTURES
FOR SEMICONDUCTOR DEVICE
INTERCONNECTS, METHODS FOR
MAKING SAME, AND
SEMICONDUCTOR DEVICES
INCLUDING SAME

Examiner: H. Nguyen

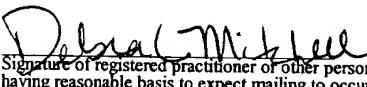
Group Art Unit: 2812

Attorney Docket No.: 3442.1US (96-428.1)

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Debra L. Mitchell
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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed April 25, 2002, the three-month shortened statutory period for response to which expires on July 25, 2002.

07/19/2002 NMOHAMM1 00000112 09829161

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